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**Microcavity Discharge Devices and Arrays: A Photonic Platform for Photodetectors, Optical Amplifiers and Displays**

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Microcavity plasma is the term associated with the spatial confinement of a nonequilibrium plasma to a cavity having a characteristic dimension below nominally 500  $\mu\text{m}$ . Recently, fabrication techniques developed largely by the semiconductor and MEMs communities have been adapted to realize a family of microcavity plasma (microplasma) devices with cross-sectional dimensions as small as  $(10 \mu\text{m})^2$ . Fabricated in a wide range of materials platforms, including Si, ceramics, and metal/dielectric multilayer structures, these devices exhibit a number of intriguing properties. These include: 1) the ability to operate on a continuous basis at pressures of one atmosphere and above, 2) specific power loadings of at least tens of  $\text{kW}\cdot\text{cm}^{-3}$ , and 3) microcavity volumes of nanoliters or picoliters. This talk will summarize the properties of microcavity plasmas with characteristic dimensions in the 10-150  $\mu\text{m}$  range, and operating at gas pressures up to  $\sim 1200$  Torr. Emphasis will be placed on the scientific opportunities afforded by: 1) the access provided by microcavity plasmas to a new region of parameter space, and 2) the ability to now interface a low temperature plasma with an electronic or optical material. Several examples of photonic structures and their applications will be presented, including the recent development of arrays of 250,000 ( $500 \times 500$ ) inverted pyramid microcavity devices fabricated in silicon. Having an active area of  $25 \text{ cm}^2$ , this array has been operated in both the rare gases and Ar/N<sub>2</sub> mixtures, and yields luminous efficacies  $>5$  lumens/W when coupled with a commercial green phosphor (Mn:Zn<sub>2</sub>SiO<sub>4</sub>). Ceramic microchips offering a microplasma gain length of 1-2 cm have also been developed and gain on the 460.3 nm transition of Xe<sup>+</sup> has been observed. Applications of microplasmas in biomedical diagnostics and optics will also be discussed.